

FORM PTO-1449 (Additional references) Page 1 of 1	Atty. Docket No.: H26341 D1 (1139.1124103)	Serial No.: 10/617,290
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant: Ralph H. Johnson et al.	
	Filing Date July 10, 2003	Group Art: unknown 2828



U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Filing Date If Appropriate
<i>[Signature]</i>	6,064,683	05/16/2000	Johnson	<i>[Signature]</i>

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Country	Translation Yes No
<i>[Signature]</i>	WO 98/07218	02/19/1998	PCT	<i>[Signature]</i>
<i>[Signature]</i>	WO 02/17445 A1	02/28/2002	PCT	
<i>[Signature]</i>	WO 03/023457 A1	03/20/2003	PCT	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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FORM PTO-1449 Page 1 of 1 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.: H26341 D1 (1139.1124103)	Serial No.: 10/617,290
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FOREIGN PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Country	Translation Yes No
	EP 0822630	02/04/1998	EP	<input checked="" type="checkbox"/>

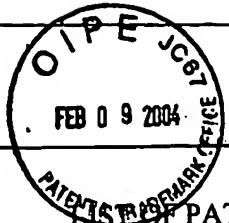
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	Tai K., et al., "90% Coupling of Top Surface Emitting GAAS/ALGAAS Quantum Well Laser Output Into 8M Diameter Core Silica Fibre," Electronics Letters, IEE Stevenage, GB, vol. 26, no. 19, September 13, 1990, pp. 1628-1629.
	Zhou D., et al., "Simplified-Antiresonant Reflecting Optical Waveguide-Type Vertical-Cavity Surface-Emitting Lasers," Applied Physics Letters, American Institute of Physics, New York, vol. 76, no. 13, March 27, 2000, pp. 1659-1661.

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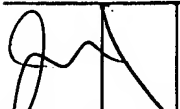
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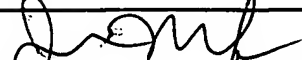
Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Class	Sub Class	Translation Yes No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	Choquette, Kent D., et al., "Design of Oxide Aperture Profile within Selectively Oxidized VCSELs, IEEE, Conference Proceedings, LEOS '98, 11th Annual Meeting, Orlando, Florida, December 1-4, 1998, pages 179-180.
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